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Substitution in 1449A/PTO

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(use as many sheets as necessary)

Sheet I of 4 Attorney Docket Number 2269-4973.1US (00-0

Examiner Cite Initials No.		Document Number	Publication Date	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant	
		Number • Kind Code <sup>2</sup> (if known)	MM-DD-YYYY	Cited Document	Passages or Relevant Figures Appear	
Mbe	1	US - 3,239,496	03/1966	Jursich	ì	
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Initials*	No.1	Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>3</sup> (If known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
Mhe		EP 0475022 A1	03/18/1992	Grube et al.	1	
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Jbe		KR 2001054744	07/2001	Choi et al. (English Abstract)		x

Examiner Signature Jasmine Clark	Date Considered 0	1/20/05
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Under the Paperwork Reduction Act of 1995, no persons are required to respond to a collection of information unless it contains a valid OMB control number. Substitute for form 1449A/PTO Complete if Known 10/782,270 INFORMATION DISCLOSURE Application Number February 18, 2004 STATEMENT BY APPLICANT Filing Date First Named Inventor Teck Kheng Lee Group Art Unit 2815 (use as many sheets as necessary) Examiner Name J. Clark 2269-4973.1US (00-0593.01/US) Attorney Docket Number

r	C:	Document Number	Publication Date	Name of Patentee or Applicant of	Pages, Columns, Lines, Where Relevant
Examiner Initials *	No. Number - Kind Code <sup>2</sup> (If known)	MM-DD-YYYY	Cited Document	Passages or Relevant Figures Appear	
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Examiner Cite	Foreign Patent Document	]	Name of Patentee or	Pages, Columns, Lines,		
Initials*	No. <sup>1</sup>	Country Code <sup>3</sup> - Number <sup>4</sup> - Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	76
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Substitute for form 1449A/PTO Complete if Known 10/782,270 Application Number INFORMATION DISCLOSURE Filing Date February 18, 2004 STATEMENT BY APPLICANT Teck Kheng Lee First Named Inventor 2815 Group Art Unit (use as many sheets as necessary) J. Clark Examiner Name 2269-4973 IUS (00-0593 01/US) Attorney Docket Number

	·	NON PATENT LITERATURE DOCUMENTS	
Examiner Initials *	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	Т <sup>2</sup>
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FORMATION DISC	LOSURE
STATEMENT BY APP	·

	Complete if Known
Application Number	10/782,270
Filing Date	February 18, 2004
First Named Inventor	Teck Kheng Lee
Group Art Unit	Unknown
Examiner Name	Unknown
Attorney Docket Number	2269-4973.1US (00-0593.01/US)

	Cite No. <sup>1</sup>	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant	
		Number - Kind Code <sup>2</sup> (if known)			Passages or Relevant Figures Appear	
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